

## GATEKEEPER® CORROSIVE (C-XPC) GAS PURIFIERS

Cost-effective gas purification



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#### Overview

Available for low-flow point-of-use, GateKeeper® corrosive XPC series gas purifiers are designed for use with Cl<sub>2</sub>, HBr, BCl<sub>3</sub>, SiCl<sub>4</sub> and SiF<sub>4</sub>. The purifiers remove moisture to <1 ppb (part-perbillion) in N<sub>2</sub>.

#### Features and Benefits

#### Cost-effective

- Gas purification improves process consistency, increases product yields and lengthens tool life
- Transforms low-purity gas into UHP grade, reducing process costs

#### **Process Protection**

- Consistently delivers ultrapure gas
- Guards against bulk gas purifier breakthrough, impurity spikes from liquid storage tanks, cylinder changeouts and unexpected contaminants in the process

- Does not release hydrocarbons that may contaminate the process
- Low pressure drop across purifiers
- CE certified to the Pressure Equipment Directive (PED) and manufactured in an ISO 9001:2000 facility
- Backed by global service and support staff

#### Safe and Simple to Use

- Easy to install
- Uses ambient temperature purification technology no power or heat required
- No moving parts

#### General Specifications

316L stainless steel, electropolished 1	10 Ra	
Cl <sub>2</sub> , HBr, BCl <sub>3</sub> , SiCl <sub>4</sub> , SiF <sub>4</sub>		
<1ppb H <sub>2</sub> O in N <sub>2</sub>		
30KF to 75KF, 300KF to 700KF	0.003 μm 316L stainless steel	
100KF	0.003 μm 316L stainless steel	
Inorganic		
1379 kPa (200 PSID)		
101 kPa (14.7 PSIA)		
$1 \times 10^{-9}$ atm cc/sec		
10 ppm (part-per-million)		
One year at nominal flow rate with 1 ppm inlet challenge of moisture		
65°C (149°F)		
	Cl <sub>2</sub> , HBr, BCl <sub>3</sub> , SiCl <sub>4</sub> , SiF <sub>4</sub> <1ppb H <sub>2</sub> 0 in N <sub>2</sub> $30KF to 75KF, 300KF to 700KF$ $100KF$ $100KF$ $100F$ $1379 kPa (200 PSID)$ $101 kPa (14.7 PSIA)$ $1 \times 10^{-9} atm cc/sec$ $10 ppm (part-per-million)$ One year at nominal flow rate with 1	

## Operating Specifications

Model	Maximum Flow Rate (SLPM)	Nominal Flow Rate (SLPM)	Maximum Operating Pressure Purifier Only¹	Maximum Operating Pressure Purifier with Options	Pressure Drop <sup>2</sup>
35KF	1	0.35	19995 kPa (2900 PSIG)	1724 kPa (250 PSIG)	3.4 kPa (0.5 PSID)
70KF	3	0.6	19995 kPa (2900 PSIG)	1724 kPa (250 PSIG)	4.8 kPa (0.7 PSID)
100KF	20	1.3	6895 kPa (1000 PSIG)	1724 kPa (250 PSIG)	27.6 kPa (4 PSID)
300KF	50	3.7	4826 kPa (700 PSIG)	1724 kPa (250 PSIG)	34.5 kPa (5 PSID)
500KF	60	7	4826 kPa (700 PSIG)	1724 kPa (250 PSIG)	48.3 kPa (7 PSID)
700KF	120	10	4826 kPa (700 PSIG)	1724 kPa (250 PSIG)	48.3 kPa (7 PSID)
Drop-in Replacements for Waferpure® Purifiers					
30KF (Micro)	1	0.35	19995 kPa (2900 PSIG)	1724 kPa (250 PSIG)	3.4 kPa (0.5 PSIG)
75KF (Mini-XL)	5	0.6	19995 kPa (2900 PSIG)	1724 kPa (250 PSIG)	10.3 kPa (1.5 PSIG)
300KF (Megaline)	50	3.7	4826 kPa (700 PSIG)	1724 kPa (250 PSIG)	34.5 kPa (5 PSIG)

<sup>&</sup>lt;sup>1</sup> Do not use under vacuum. Minimum pressure should be 1 atm (14.7 PSIA). <sup>2</sup> Pressure drop at maximum flow rate and 90 PSIG (620 kPa) inlet pressure. For a detailed pressure drop curve and other pressures or flows, please consult your local sales representative or visit www.entegris.com.

## Facility Specifications

Model	Fitting Sizes	Configuration (inlet/outlet)	Approximate Weight	Length	Diameter	Fitting Offset
35KF	1/4" face seal	male/male	0.3 kg (0.66 lb)	8.4 cm (3.31")	3.8 cm (1.5")	Centered
70KF	1/4" face seal	male/male	0.4 kg (0.88 lb)	11.4 cm (4.5")	3.8 cm (1.5")	Centered
100KF	1/4" face seal	male/male	0.5 kg (1.1 lb)	8.4 cm (3.31")	15.2 cm (6") <sup>3</sup>	1.12 cm (0.44")
300KF	1/4" face seal	male/male	1.8 kg (4 lb)	20.8 cm (8.2")	5.1 cm (2")	Centered
500KF	1/4" face seal	male/male	1.6 kg (3.5 lb)	20.2 cm (7.94")	7.6 cm (3")	Centered
700KF	1/4" face seal	male/male	1.6 kg (3.5 lb)	25.4 cm (10")	7.6 cm (3")	Centered
Drop-in Replaceme	ents for Waferp	ure Purifiers				
30KF (Micro)	1/4" face seal	male/male	0.3 kg (0.66 lb)	8.4 cm (3.31")	3.8 cm (1.5")	0.97 cm (0.38")
75KF (Mini-XL)	1/4" face seal	male/male	0.4 kg (0.88 lb)	12.7 cm (5")	3.8 cm (1.5")	0.97 cm (0.38")
300KF (Megaline)	1/4" face seal	male/male	1.8 kg (4 lb)	20.8 cm (8.2")	5.1 cm (2")	Centered

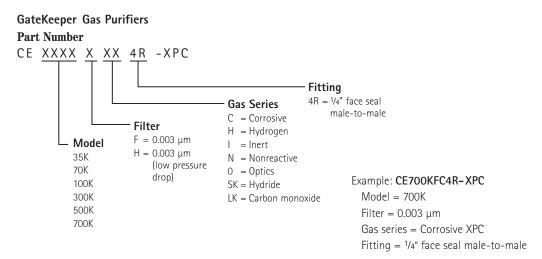
<sup>&</sup>lt;sup>3</sup> Height

### Options

Model	Isolation Valves	GC 300 Manifold	3 Valve Bypass Manifold	5 Valve Bypass Manifold
35KF	Yes		Yes	Yes
70KF	Yes		Yes	Yes
100KF				
300KF	Yes	Yes		
500KF	Yes		Yes	Yes
700KF	Yes			
Drop-in Replacements for	r Waferpure Purifiers			
30KF (Micro)	Yes		Yes	Yes
75KF (Mini-XL)	Yes		Yes	Yes
300KF (Megaline)	Yes	Yes		

All product information is subject to change without notice.

#### **Ordering Information**



For detailed product information including dimensional drawings, pressure drop curves, safety information and for help selecting a purifier and determining purifier lifetimes, please visit our website at *www.entegris.com*. Go to Products>Purification>Gas Purification.

All products meet CE Directive 97-23-EC requirements.



Note: Not all models are available with all gas series, fittings, or additional processing; contact your salesperson for more information.

Note: For Mykrolis® replacement, specify 30K, 75K or 300K for all models.

#### For More Information

Please call your Regional Customer Service Center today to learn what Entegris can do for you. Visit *www.entegris.com* and select the "Customer Service" link for the center nearest you.

#### Terms and Conditions of Sale

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